

# LITHIUM-TITANATE THIN FILMS BY SOLID STATE REACTION AS ELECTRODE MATERIAL FOR LITHIUM-ION BATTERIES

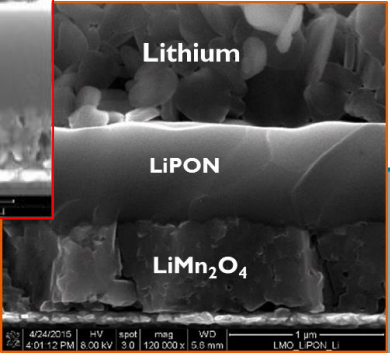
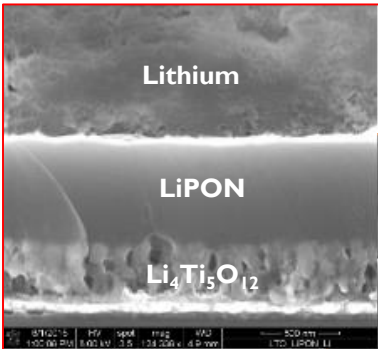
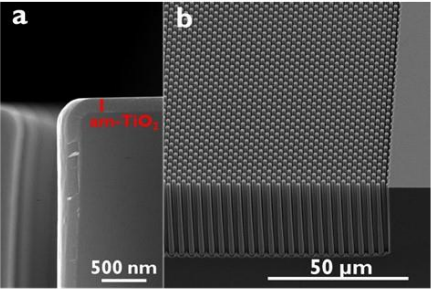
NOUHA LABYEDH, BRECHT PUT, ABDEL-AZIZ EL MEL, AN HARDY, MARLIES K. VAN BAELE, PHILIPPE M. VEREECKEN

A decorative background graphic consisting of a series of overlapping, wavy lines made of small dots, transitioning from purple on the left to blue on the right.

**KU LEUVEN**

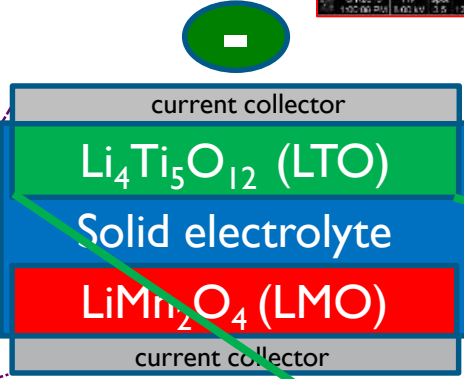
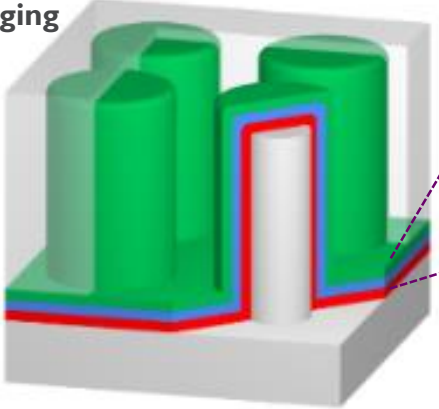
ASPIRE  
INVENT  
ACHIEVE

# THIN-FILM BATTERIES

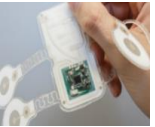


Fast Charging

125-150 μm



Alternative  $\text{Li}_4\text{Ti}_5\text{O}_{12}$  thin films fabrication method that can be used for making thin-film batteries on planar and 3D microstructured substrates

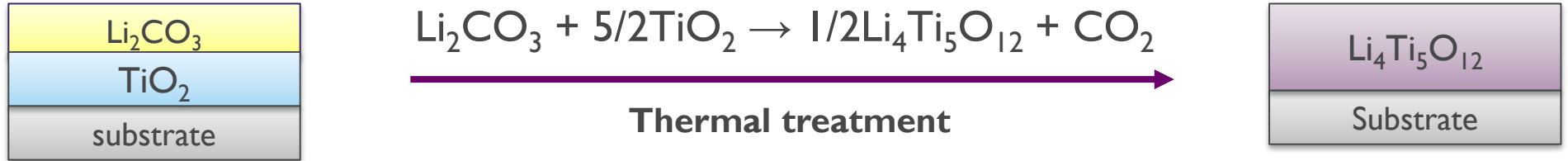


Smart cards, patches, wearables and flexible electronics...

# PROPOSED FABRICATION PROCESS: $\text{Li}_4\text{Ti}_5\text{O}_{12}$ THIN FILMS BY SOLID STATE REACTION

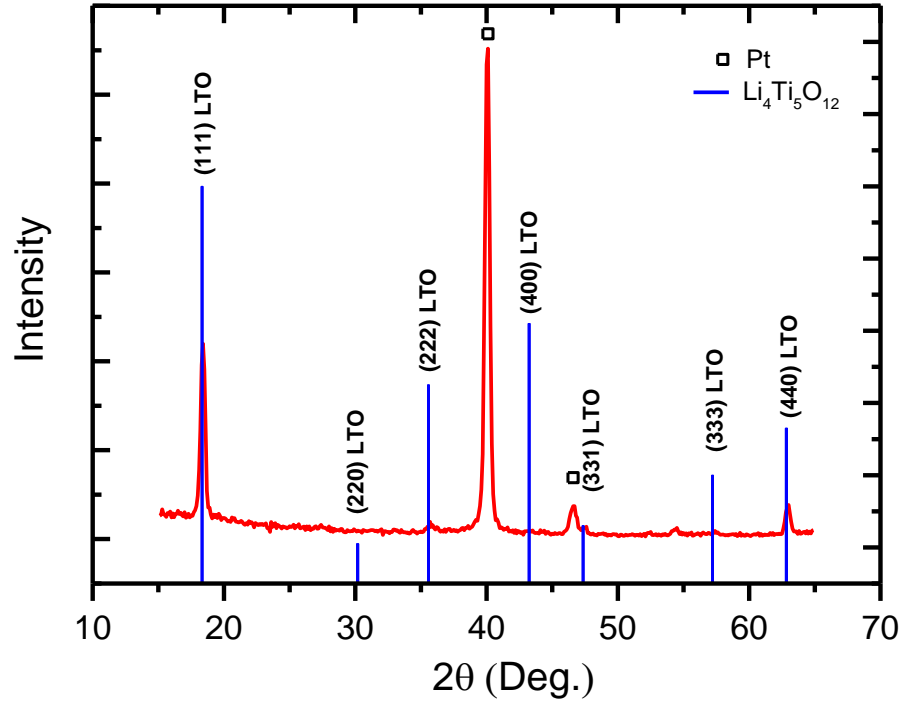
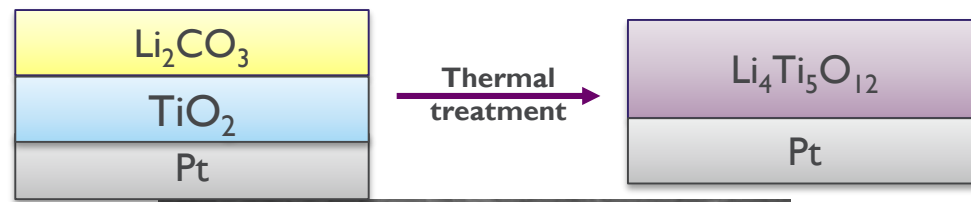
The fabrication by solid state reaction is a very known technique for making powder material

→ Apply this fabrication method to make thin films

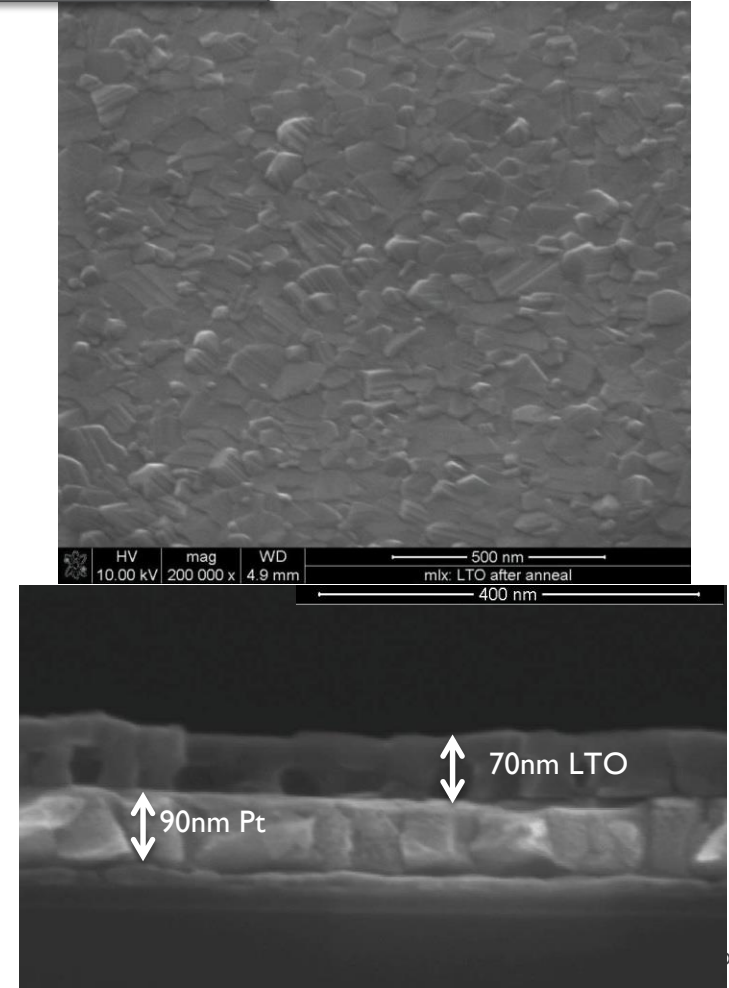


The  $\text{TiO}_2$  layer is deposited by sputtering or atomic layer deposition (ALD)  
The  $\text{Li}_2\text{CO}_3$  layer is deposited by spincoating

# PHASE AND MORPHOLOGY

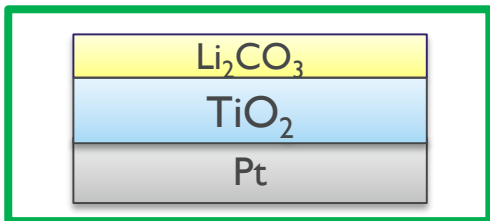


- Characteristic diffraction peaks of spinel  $\text{Li}_4\text{Ti}_5\text{O}_{12}$
- Continuous 70 nm thick film with a crystalline morphology



# XPS SURFACE SPECTRA BEFORE AND AFTER ANNEALING

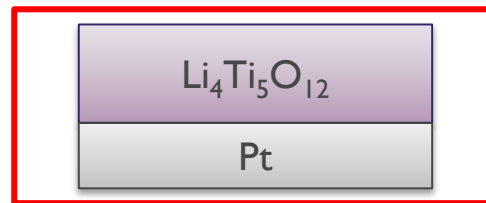
As deposited



Thermal treatment

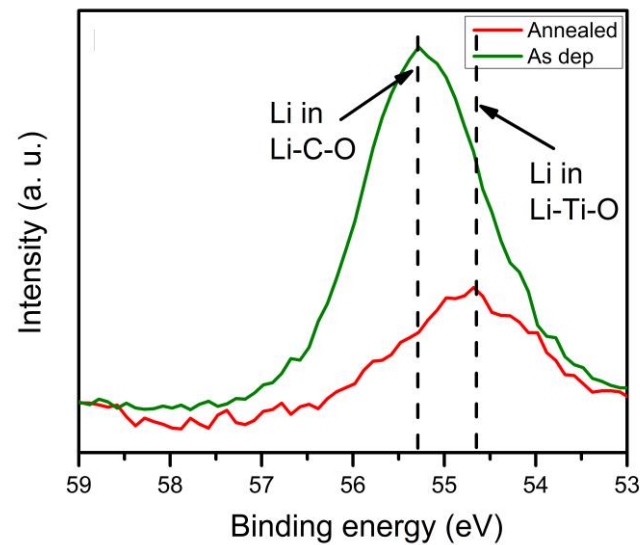
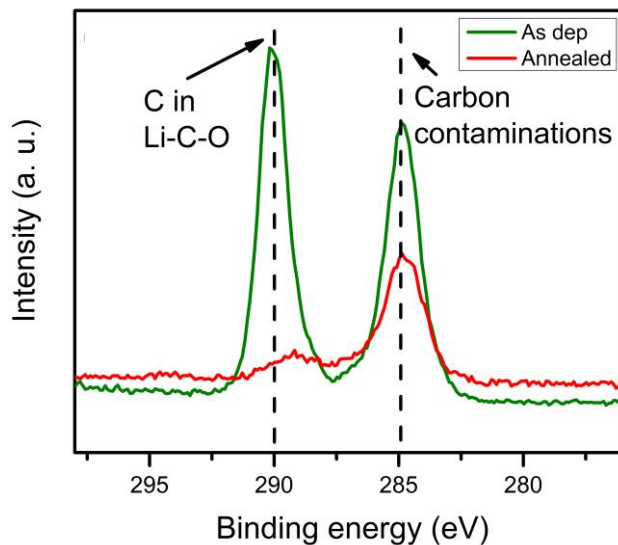
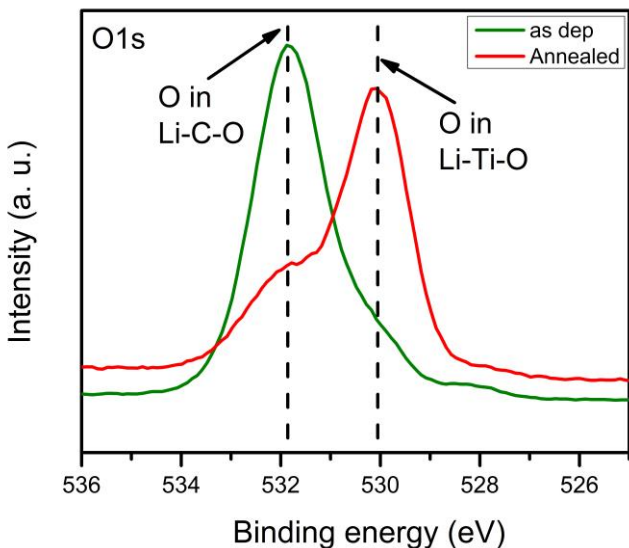


After annealing



C1s

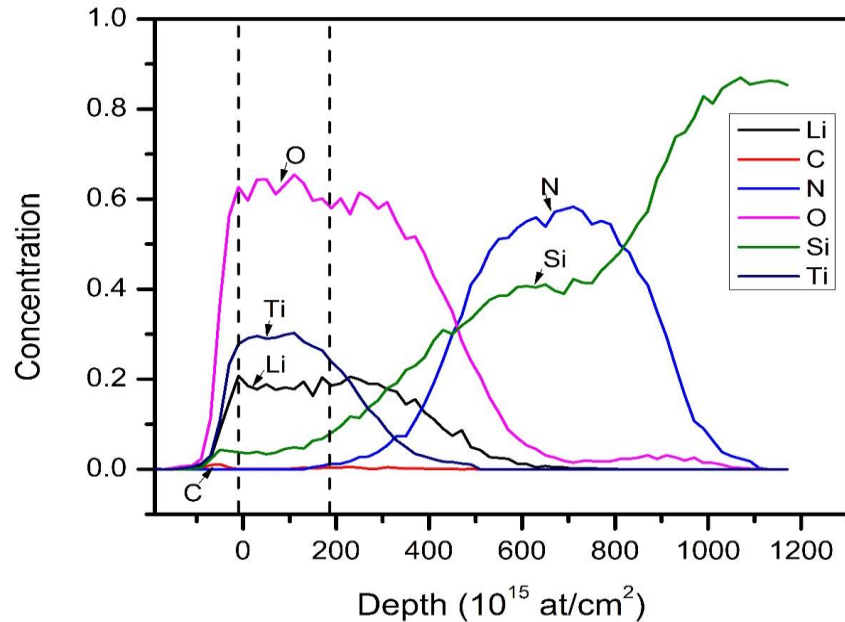
Li1s



The thermal treatment causes elements intermixing and the LTO material formation  
Excess of  $\text{Li}_2\text{CO}_3$  is detected after annealing

# STOICHIOMETRY AND ELEMENTS DISTRIBUTION

ERDA (ELASTIC RECOIL DETECTION ANALYSIS)

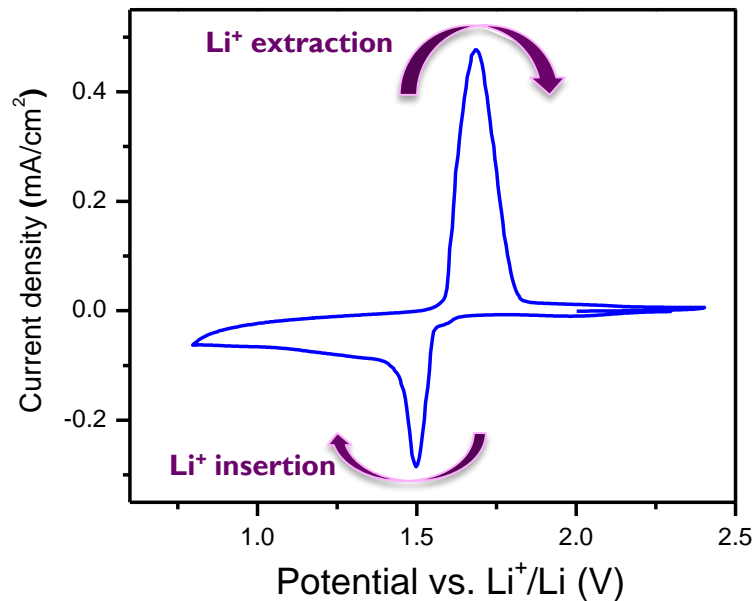


	Elements ratio of the prepared film (ERDA)	Theoretical elements ratio in LTO
Li	18 %	19 %
Ti	26 %	24 %
O	56 %	57 %

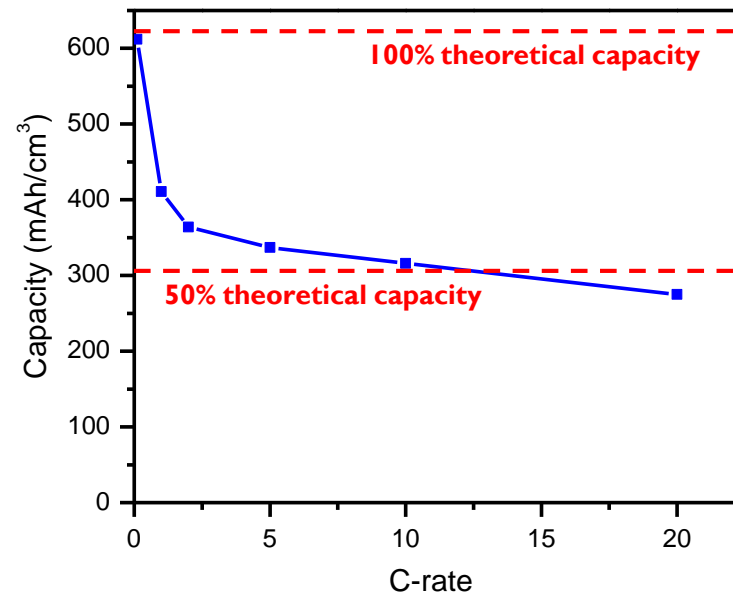
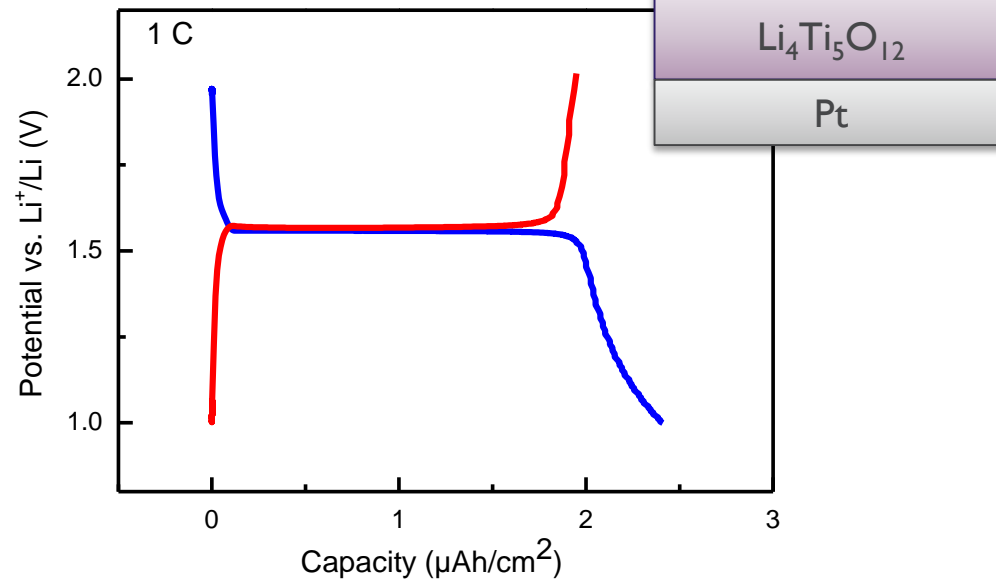
- Homogeneous elements distribution through the LTO layer
- Stoichiometry close to the theoretical stoichiometry of  $\text{Li}_4\text{Ti}_5\text{O}_{12}$



# ELECTROCHEMICAL ACTIVITY



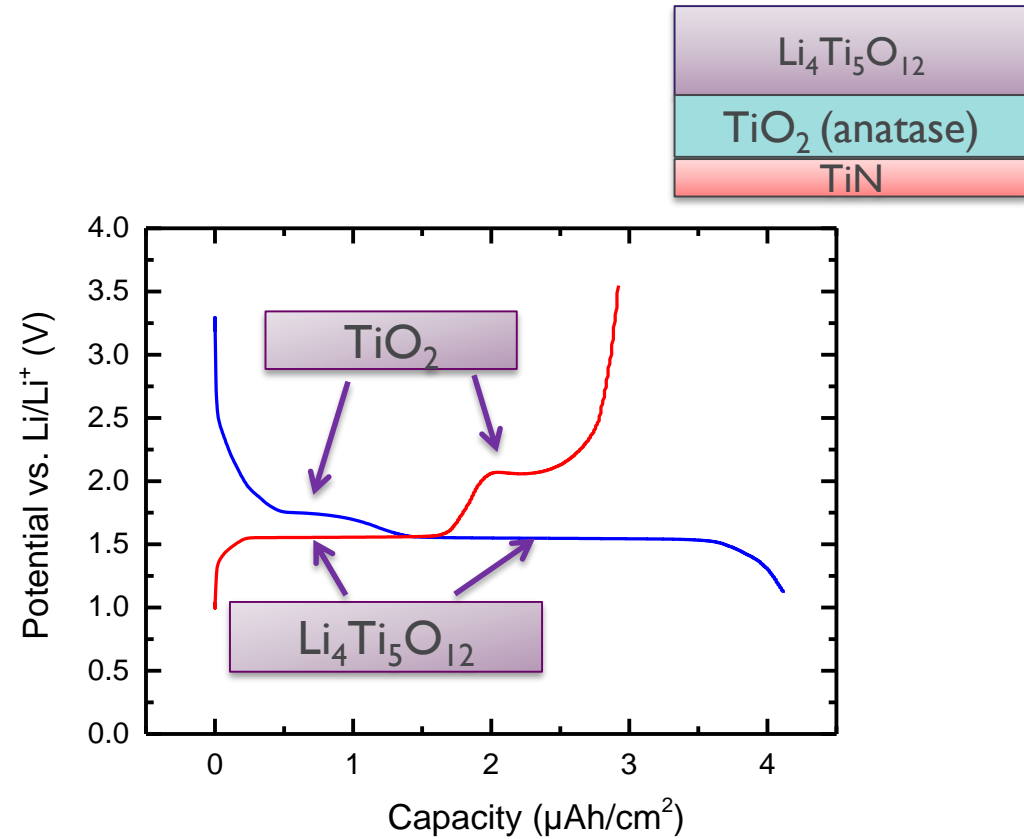
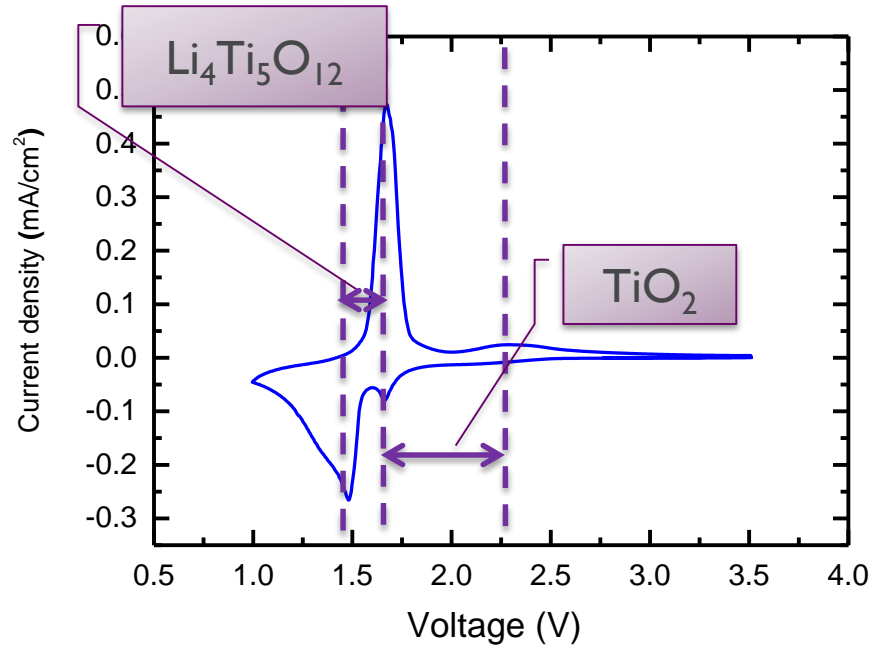
- Redox peak attributed to Li<sup>+</sup> insertion/extraction in/from LTO
- Flat potential plateaus at 1.55 V vs. Li<sup>+</sup>/Li typical for Li<sub>4</sub>Ti<sub>5</sub>O<sub>12</sub>
- Theoretical capacity reached at 0.1C
- 45% of the theoretical capacity at 20C







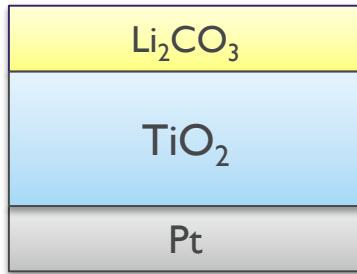
# ELECTROCHEMICAL ACTIVITY



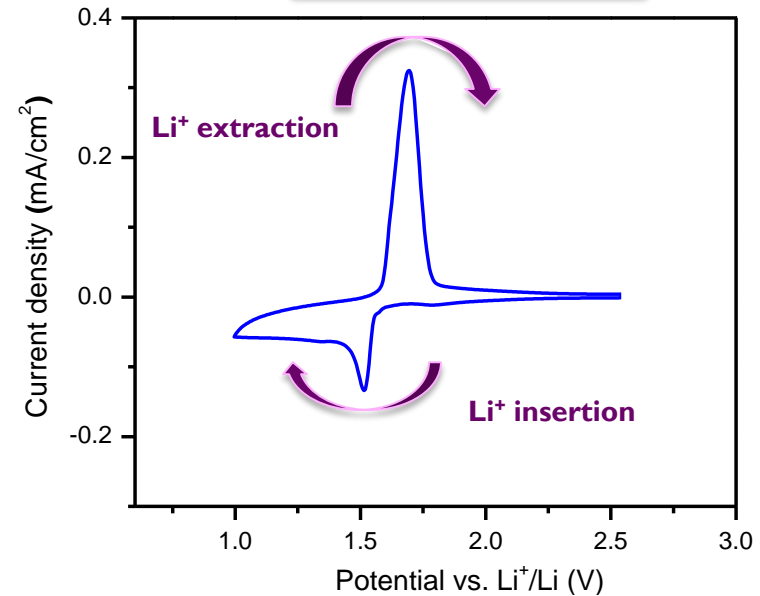
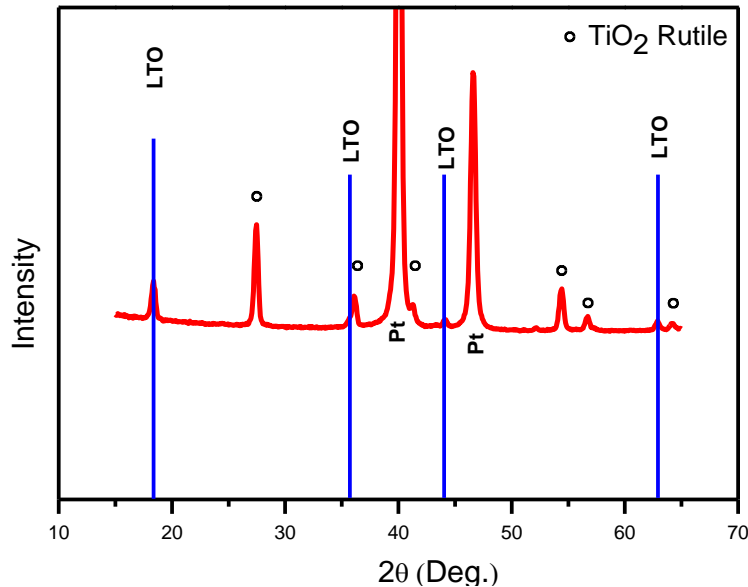
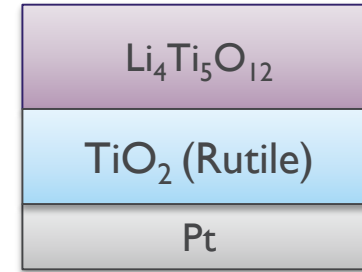
Redox peaks attributed to  $\text{Li}_4\text{Ti}_5\text{O}_{12}$  and  $\text{TiO}_2$

2 operational plateaus for  $\text{Li}_4\text{Ti}_5\text{O}_{12}$  and  $\text{TiO}_2$

# $\text{Li}_4\text{Ti}_5\text{O}_{12}$ WITH RUTILE IMPURITIES



Thermal treatment



Spinel LTO diffraction peaks together with rutile TiO<sub>2</sub> and Pt substrate peaks  
Only LTO redox peaks → the rutile TiO<sub>2</sub> is not electrochemically active

# ELECTROCHEMICAL ANALYSIS OF THE DIFFERENT STACKS

Sample stack	impurities	Cyclic voltammetry (10 mV/s)	
		LTO normalized thickness	TiO <sub>2</sub> thickness (nm)
LTO/PT	--	81%	N.A
LTO/Anatase TiO <sub>2</sub> /TiN	Anatase	100 %	16 nm
LTO/Rutile TiO <sub>2</sub> /PT	Rutile	22 %	N.A

The sample with LTO and anatase TiO<sub>2</sub> on TiN shows the best electrochemical performance: → The anatase TiO<sub>2</sub> contributes to the Li<sup>+</sup> insertion/extraction process

→ LTO/AnataseTiO<sub>2</sub>/TiN has better interfaces than LTO/Pt

The rutile TiO<sub>2</sub> is not electrochemically active and inhibits the LTO kinetics

# SUMMARY AND CONCLUSION

- $\text{Li}_4\text{Ti}_5\text{O}_{12}$  thin films can be formed by solid state reaction with homogenous element distribution and stoichiometry close to the theoretical LTO stoichiometry
- The  $\text{Li}_4\text{Ti}_5\text{O}_{12}$  films formed by solid state reaction are electrochemically active
- The theoretical capacity can be reached at 0.1 C and 45% of it is reached at 20 C
- The presence of rutile  $\text{TiO}_2$  impurities blocks the LTO kinetics while the anatase  $\text{TiO}_2$  contributes to the Li-ion insertion/extraction process leading to a better electrochemical performance of the film

# ACKNOWLEDGEMENT



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The Estore team at imec

ASPIRE  
INVENT  
ACHIEVE

**Thank you for your kind attention!**  
**Question?**

